JUL 16 2007

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application	of:)
Steven Verl	naberbeke et al.))
Application No:	09/891,849) Examiner: Markoff, Alexander
Filed:	June 25, 2001) Art Unit: 1746
For: METHOD AND APPARATUS FOR WAFER CLEANING) Confirmation No: 4749)
Commissioner for P.O. Box 1450 Alexandria, VA 22		/
	PRELIMINARY A	MENDMENT
Dear Sir:		
This is in re	sponse to the Final Office	Action mailed May 16, 2007 and the
Request for Contir	nued Examination (RCE) ui	nder 37 C.F.R. § 1.114 filed concurrently
herewith. Applica	ant respectfully requests the	e Examiner to enter this Preliminary
Amendment and o	consider the following rema	arks.
	FIRST CLASS CERTIFIC	ATE OF MAILING
sufficient postage in an e COMMISSIONER FOR I	correspondence is being deposited envelope addressed to MAIL STOP PATENTS, P.O. Box 1450, Alexandriark Office, Washington, D.C. 20231	ia, VA 22313-1450
	esa Mattox	
Terage N	ne of Person Mailing Corresponden	
Sign	ature /	Date

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Attorney Docket: 004711/P1 BSTZ Ref. No.: 004887.P454X